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Typed or printed name: EIA M. Lynch  
Signature: EIA M. Lynch

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Yu Wang et al.

: Group Art Unit: 3744

Application No. 10/766,140

: Examiner: W.C. Doerrler

Filed: January 27, 2004

: Response to Paper No. 20050401

For: VACUUM RETENTION METHOD  
AND SUPERCONDUCTING  
MACHINE WITH VACUUM  
RETENTION

**AMENDMENT UNDER 37 CFR 1.111**

Assistant Commissioner for Patents  
Alexandria, VA 22313-1450

S I R:

In response to the non-final Office Action dated April 22, 2005, Applicants respectfully request that the above-identified application be amended as follows.